



Thre the Application of: INOUE, et al.

Serial No.: **08/921,250**

Filed: August 29, 1997

Corres. and Mail

Group Art Unit: 1763

Examiner: GOUDREAU

For. FABRICATION METHOD OF SEMICONDUCTOR DEVICE AND ABRASIVE LIQUID USED THEREIN

RESPONSE UNDER 37 CFR §1.116
- EXPEDITED RESPONSE GROUP ART UNIT 1763

BOX AF

Commissioner for Patents Washington, D.C. 20231

September 5, 2002

Sir:

In response to the Office Action dated **June 5, 2002**, please amend the above-identified application as follows:

IN THE CLAIMS:

Please cancel claims 10 and 18 without prejudice or disclaimer.

